



EBARA TECHNOLOGIES, INCORPORATED
51 MAIN AVENUE, SACRAMENTO, CA 95838 U.S.A
PHONE (916) 920-5451
www.ebaratech.com

Brandon Weis promoted to Vice President and General Manager, Semiconductor Equipment Division, EBARA Technologies Inc.

Sacramento, California – July 31, 2023.

Ebara Technologies Inc. (ETI), a global leader in products for semiconductor manufacturing technologies, is pleased to announce that Brandon Weis has been appointed as ETI's Vice President & General Manager, Systems Equipment Division, effective July 5, 2023. Since first joining ETI in 2000, Brandon has served various roles in the Process Engineering and Customer Service department starting as an Applications Engineer, Engineering Manager and then moving to Director of Applications and Process Engineering.



In his most recent role as the Director of Applications & Process Engineering, he oversaw strategic evaluations of our latest CMP technology platforms at customer sites to further business growth. During this time, he also oversaw the Ebara Technologies development labs for leading edge processes to support global customer roadmaps.

According to Sachin Paradkar, President & CEO "Ebara Technologies is pleased to give Brandon Weis the chance to use his years of experience within our organization to better serve our customers. We fully expect Brandon will be an asset in the years to come that allows us to provide our customers with the high-quality products and services they deserve while enabling us to achieve our goals for growth as a company."

About EBARA Technologies, Inc.

EBARA Technologies, Inc. is a U.S. based subsidiary of EBARA Corporation, a Japanese company founded in 1912, which provides a wide range of technologies including equipment, systems and services for water, air and the environment. EBARA Technologies, Inc. is a leading global innovator and worldwide supplier of vacuum technologies and advanced wafer-processing equipment for clean environments within the semiconductor industry. EBARA manufactures a full line of Dry Mechanical Pumps, Turbomolecular Pumps for the semiconductor industry's toughest applications, including LPCVD, etch, EPI and Ion Implant. The company's offerings also include a complete line of Vacuum Valves and Fittings, Heaters for vacuum and exhaust lines, Point-of-Use Abatement systems, Ozonized water and gas equipment. Our systems group manufactures Chemical Mechanical Polishers (CMP), Bevel Edge Polishing Systems (EAC), and Through-Mask Plating Systems (ThMP). EBARA maintains a superior sales and support network in the U.S. and worldwide. www.ebaratech.com.